

## EUROPEAN CREDIT TRANSFER AND ACCUMULATION SYSTEM (ECTS)

pl. M. Skłodowskiej-Curie 5, 60-965 Poznań

# **COURSE DESCRIPTION CARD - SYLLABUS**

Course name

Modern imaging techniques in mechanical engineering

Course

Field of study Year/Semester

Mechanical Engineering 2/3

Area of study (specialization) Profile of study

Mechanical Engineering general academic
Level of study Course offered in

Second-cycle studies polish

Form of study Requirements

full-time elective

Number of hours

Lecture Laboratory classes Other (e.g. online)

15 15

Tutorials Projects/seminars

**Number of credit points** 

2

#### Lecturers

Responsible for the course/lecturer:

prof. Ewa STACHOWSKA Ph.D., D.Sc., Eng. Bartosz GAPIŃSKI

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Faculty of Mechanical Engineering
Ph.D., Eng. Karol GROCHALSKI

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Responsible for the course/lecturer:

## **Prerequisites**

Knowledge of basics of metrology as well as mathematical analysis and statistics, technical drawing,



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machine parts and non-destructive testing. Willingness to acquire new knowledge and skills. The ability to think logically and use information obtained from various sources.

## **Course objective**

Acquainting with non-destructive methods in metrology in machine building and control of industrial facilities

## **Course-related learning outcomes**

## Knowledge

- 1. The student should characterize methods of non-destructive testing in metrology [K W13]
- 2. The student should characterize the basic devices used in non-destructive testing [K W13]

#### Skills

- 1. The student is able to select the device for the measuring task [K\_U17]
- 2. The student is able to develop a basic measurement strategy [K\_U17]
- 3. The student is able to develop and analyze obtained results [K\_U17]

# Social competences

- 1. The student is able to work in a group [K KO3]
- 2. The student is aware of the role of non-destructive testing in the modern economy [K\_K02]

## Methods for verifying learning outcomes and assessment criteria

Learning outcomes presented above are verified as follows:

Lecture: written or oral test

Laboratory: crediting on the base of an oral or written answer concerning the content of each performed laboratory exercise and preparation of reports. In order to pass the classes, all exercises must be completed.

### **Programme content**

#### Lecture:

- 1. Definition, structure and tasks of non-destructive testing in metrology.
- 2. Measuring devices used for non-destructive testing.
- 3. Passive thermography.
- 4. Active thermography.
- 5. Sources of excitations in active thermography.
- 6. Examination of welded joints.



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- 7. Tests of the thickness of coatings.
- 8. X-ray computed tomography.
- 9. Possibilities of product evaluation on the basis of computed tomography.
- 10. Vibrometry and holographic microscopy, optical interferometry and shearography to assess local deformations and stresses of materials.

## Laboratory:

- 1. Measurements using a thermographic camera.
- 2. Measurements with the use of an active thermal imaging system.
- 3. Measurements with the use of computed tomography basics.
- 4. Detection of defects and non-destructive testing with the use of computed tomography.
- 5. Measurements using optical interferometric methods.
- 6. Detection by non-contact methods: shearographic and holographic local deformations, stresses and internal defects.

# **Teaching methods**

Lecture: multimedia presentation illustrated with examples given on the whiteboard and films.

Laboratory exercises: performing experiments, case study, discussion, working in a group.

### **Bibliography**

#### Basic

- B. Więcek, G de Mey: "Termowizja w podczerwieni. Podstawy i zastosowania", Wydawnictwo PAK, Warszawa, 2011.
- W. Minkina: "Pomiary termowizyjne przyrządy i metody", Wydawnictwo Politechniki Częstochowskiej, Częstochowa 2004.
- E. Ratajczyk, A. Woźniak: "Współrzędnościowe systemy pomiarowe", Wydawnictwo Politechniki Warszawskiej, Warszawa 2016.
- K. Patorski, M.Kujawińska, L.Sałbut: "Interferometria laserowa z automatyczną analizą obrazu", Oficyna Wydawnicza Politechniki Warszawskiej, Warszawa 2005.
- E. Hecht, "Optyka" Wydawnictwo Naukowe PWN, Warszawa 2012.



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## Additional

- O. Breitenstein, M. Langenkamp: "Lock-in Thermography", Springer-Verlag Berlin, Heildelberg 2003
- X. Maldague: "Theory and Practice of Infrared Technology for Nondestructive Testing". John Wiley & Sons Inc., New York 2001.
- R. Christopg, H.J. Neumann: "X-ray Tomography in Industrial Metrology, Precise, Economical and Universal", Verlag Moderne Industrie 2011, ISBN 978-3-86236-020-8.
- B. Ziętek: "Optoelektronika", Wydawnictwo Uniwersytetu Mikołaja Kopernika, Toruń 2005.
- P. Hariharan: "Optical Holography; Principles, Techniques and Applications", Cambridge University Press, 2nd edition, Cambridge 2008.
- B. Gapiński: "Obrazowanie i pomiary w technicznej tomografii komputerowej ze szcze-gólnym uwzględnieniem przedmiotów wykonanych technikami przyrostowymi i analizy nierówności powierzchni". Wydawnictwo Studio Poligrafia, ISBN 978-83-953889-0-3, 2019.

## Breakdown of average student's workload

	Hours	ECTS
Total workload	60	2,0
Classes requiring direct contact with the teacher	35	1,0
Student's own work (literature studies, preparation for	25	1,0
laboratory classes/tutorials, preparation for tests/exam, project		
preparation) <sup>1</sup>		

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<sup>&</sup>lt;sup>1</sup> delete or add other activities as appropriate